



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 25, 2026	
IGI Report Number	LG802609163
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.45 - 6.48 X 3.97 MM

GRADING RESULTS

Carat Weight	1.00 CARAT
Color Grade	D
Clarity Grade	VS 2
Cut Grade	IDEAL

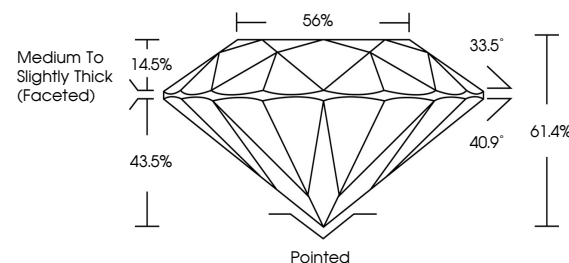
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG802609163

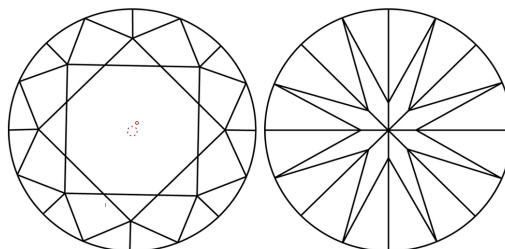
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG802609163
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

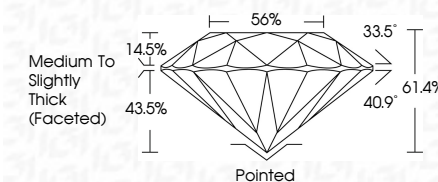
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www.igi.org

	VIS 2	D	1.00 CARAT
	IDPL		
	61.4%		
	58%		
	Medium to Slightly Thick Faceted)		
Culet	Poished		
Polish	EXCELLENT		
Symmetry	EXCELLENT		
Fluorescence	NONE		
Inscriptions(s)	#9 LSGD209165		
Comments:			
Grown Diamond was created by Chemical Vapor Deposition CVD growth process.			
Type IIA			